

In re: Tsumori et al.
Serial No.: 10/646,500
Filed: August 22, 2003
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In the Claims:

1. (Currently Amended) A plated substrate adapted for hard disk medium comprising
a Si single crystal substrate;
an amorphous layer on the substrate, the amorphous layer having thickness of 2 to 200nm and containing Si and one or more metals selected from a group consisting of Ni, Cu and Ag; and
a ~~multicrystal~~ multicrystal layer on the amorphous layer, the multicrystal layer having thickness of 5 to 1000nm and containing Si and one or more metals selected from a group consisting of Ni, Cu and Ag.

2. – 5. (Cancelled)